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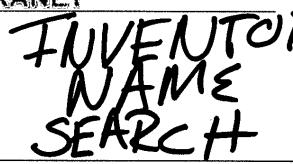


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Inventor Name Search Result

Your Search was:

Last Name = JOHN First Name = WAYNE



Application#	Patent#	Status	Date Filed	Title	Inventor Name 51
60307183	Not Issued	159		VARIABLE ASPECT RATIO PLASMA SOURCE	JOHNSON, WAYNE L.
60239922	Not Issued	159	10/13/2000	METHOD OF WAFER BAND- EDGE MEASUREMENT USING SPECULAR REFLECTION SPECTROSCOPY AND A PROCESS FOR CONTROLLING THE TEMPERATURE UNIFORMITY OF A WAFER	JOHNSON, WAYNE L.
60224217	Not Issued	159		METHOD AND APPARATUS FOR TUNING A PLASMA REACTOR CHAMBER	JOHNSON, WAYNE L.
60219453	Not Issued	159		ELECTRODE APPARATUS AND METHOD FOR PLASMA PROCESSING	JOHNSON, WAYNE L.
60208568	Not Issued	159		APPARATUS AND METHOD FOR IMPROVING ELECTRON ACCELERATION	JOHNSON, WAYNE L.
60203909	Not Issued	159		METHOD OF ADJUSTING THE THICKNESS OF AN ELECTRODE IN A PLASMA PROCESSING SYSTEM	JOHNSON, WAYNE L.
60202174	Not Issued	159		DEVICE AND METHOD FOR MEASURING PLASMA UNIFORMITY IN-SITU AT WAFER LEVEL	JOHNSON, WAYNE L.
60193250	Not Issued	159		OPTICAL MONITORING AND CONTROL SYSTEM AND METHOD FOR PLASMA REACTORS	JOHNSON, WAYNE L
60190099	Not Issued	159		HIGH SPEED PHOTORESIST STRIPPING CHAMBER	JOHNSON, WAYNE L.
60190098	Not Issued	159		HIGH SPEED STRIPPING FOR DAMAGED PHOTORESIST	JOHNSON, WAYNE L.
60190096	Not Issued	159		CHUCK TRANSPORT METHOD AND SYSTEM	JOHNSON, WAYNE L.
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60189043	Not Issued	159	03/14/2000	METHOD OF WAFER BAND- EDGE MEASUREMENT USING TRANSMISSION SPECTROSCOPY AND A PROCESS FOR CONTROLLING THE TEMPERATURE UNIFORMITY OF A WAFER	
60186331	Not Issued	159	03/02/2000	ESRF SOURCE FOR ION PLATING EPITAXIAL DEPOSITION	JOHNSON, WAYNE L.
60186279	Not Issued	159	03/01/2000	ELECTRICALLY CONTROLLED PLASMA UNIFORMITY IN A HIGH DENSITY PLASMA SOURCE	JOHNSON, WAYNE L.
60185069	Not Issued	159	02/25/2000	MULTI-ZONE RF ELECTRODE FOR FIELD/PLASMA UNIFORMITY CONTROL IN CAPACITIVE PLASMA SOURCES	JOHNSON, WAYNE
60185068	Not Issued	159	02/25/2000	METHOD AND APPARATUS FOR DEPOSITING FILMS	JOHNSON, WAYNE L.
60182549	Not Issued	159	02/15/2000	ACTIVE CONTROL OF ELECTRON TEMPERATURE IN AN ELECTROSTATICALLY SHIELDED RADIO FREQUENCY PLASMA SOURCE	JOHNSON, WAYNE L.
60182202	Not Issued	159		STRUCTURE AND THE METHOD FOR MEASURING THE SPECTRAL CONTENT OF AN ELECTRIC FIELD AS A FUNCTION OF POSITION INSIDE A PLASMA	JOHNSON, WAYNE L.
60182188	Not Issued	159		DEVICE AND METHOD FOR COUPLING TWO CIRCUIT COMPONENTS WHICH HAVE DIFFERENT IMPEDANCES	JOHNSON, WAYNE L.
60182187	Not Issued	159		METHOD AND DEVICE FOR ATTENUATING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	JOHNSON, WAYNE L.
29144339	D455662	150	01/01/0001	TOILET TRAINING TIMEPIECE	JOHNSTON, WAYNE L.
10755230	Not Issued	030		VARIABLE ASPECT RATIO PLASMA SOURCE	JOHNSON, WAYNE L.
10743264	Not Issued	020	I II	INTER-STAGE PLASMA SOURCE	JOHNSON, WAYNE L.
<u>10685770</u>	Not	030	10/14/2003	CABLE TROUGH METHOD	JOHNSON,

	Issued	-		WITH SEPARATE SIDE ELEMENTS	WAYNE
10630783	Not Issued	030	07/31/2003	METHOD AND APPARATUS FOR ACTIVE TEMPERATURE CONTROL OF SUSCEPTORS	JOHNSON, WAYNE L.
<u>10626106</u>	Not Issued	030	07/23/2003	TELESCOPING TROUGH	JOHNSON, WAYNE ALBIN
10398652	Not Issued	030	08/29/2003	APPARATUS FOR MEASURING TEMPERATURES OF A WAFER USING SPECULAR REFLECTION SPECTROSCOPY	JOHNSON, WAYNE L.
10031570	Not Issued	041	03/28/2002	ELECTRON DENSITY MEASUREMENT AND PLASMA PROCESS CONTROL SYSTEM USING CHANGES IN THE RESONANT FREQUENCY OF AN OPEN RESONATOR CONTAINING THE PLASMA	JOHNSON, WAYNE L.
<u>09984760</u>	6535785	150	10/31/2001	SYSTEM AND METHOD FOR MONITORING AND CONTROLLING GAS PLASMA PROCESSES	JOHNSON, WAYNE
09969170	6757673	150		DISPLAYING HIERARCHICAL RELATIONSHIP OF DATA ACCESSED VIA SUBJECT INDEX	JOHNSON, WAYNE L.
09946887	Not Issued	161	09/04/2001	METHOD OF ANALYZING, ORGANIZING AND VISUALIZING CHEMICAL DATA WITH FEATURE HIERARCHY	JOHNSON, WAYNE P.
09927838	6726742	150		AIR CLEANER WITH A SECONDARY INTAKE	JOHNSON, WAYNE E. A.
09904280	Not Issued	020		OPTIC CABLE EXIT TROUGH WITH BYPASS	JOHNSON, WAYNE ALBIN
<u>09869766</u>	6559601	150	07/02/2001	PLASMA VACUUM PUMP	JOHNSON, WAYNE L.
09869245	6530342	150		LARGE AREA PLASMA SOURCE	JOHNSON, WAYNE L.
09686167	6511577	150		REDUCED IMPEDANCE CHAMBER	JOHNSON, WAYNE L.
09680866	6512875	150		OPTICAL CABLE TROUGHS, FITTINGS, AND COUPLINGS	JOHNSON, WAYNE
09680700	6625373	150		CABLE EXIT TROUGH WITH INSERT	JOHNSON, WAYNE
09669279	6631875	150			JOHNSON, WAYNE

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09661892	6478030	150	09/14/2000	METHODS OF ENGAGING AND RELEASING A SURGICAL DEVICE TO A HANDLE	JOHNSON, WAYNE
09637526	Not Issued	041	08/10/2000	HARDWARE-SOFTWARE INTERFACE DESIGNER	JOHNSTON, WAYNE FRANKLIN
09611125	Not Issued	164	07/06/2000	APPARATUS FOR METERING MERCURY FOR LAMP DOSING	JOHNSON, WAYNE
09578300	6739795	150	05/25/2000	TELESCOPING TROUGH	JOHNSON, WAYNE ALBIN
09530946	6425953	150	06/29/2000	ALL-SURFACE BIASABLE AND/OR TEMPERATURE- CONTROLLED ELECTROSTATICALLY- SHIELDED RF PLASMA SOURCE	JOHNSON, WAYNE L.
09509556	6392187	150	05/09/2000	APPARATUS AND METHOD FOR UTILIZING A PLASMA DENSITY GRADIENT TO PRODUCE A FLOW OF PARTICLES	JOHNSON, WAYNE L.
09509549	6339206	150	:	APPARATUS AND METHOD FOR ADJUSTING DENSITY DISTRIBUTION OF A PLASMA	JOHNSON, WAYNE L.
<u>09508105</u>	6351683	150		SYSTEM AND METHOD FOR MONITORING AND CONTROLLING GAS PLASMA PROCESSES	JOHNSON, WAYNE
09508103	6313584	150		ELECTRICAL IMPEDANCE MATCHING SYSTEM AND METHOD	JOHNSON, WAYNE L.
09508102	6332961	150		DEVICE AND METHOD FOR DETECTING AND PREVENTING ARCING IN RF PLASMA SYSTEMS	JOHNSON, WAYNE L.
09497901	6209611	150	1	COLLAPSIBLE COVER APPARATUS	JOHNSON, WAYNE
09480522	6135420	150			JOHNSTON, WAYNE L.

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Inventor Name Search Result

Your Search was:

Last Name = JOHN First Name = WAYNE

Application#	Patent#	Status	Date Filed	Title	Inventor Name 51	
60352546	Not Issued	159	01/31/2002	METHOD AND APPARATUS FOR DETERMINATION AND CONTROL OF PLASM STATE	JOHNSON, WAYNE L.	
60345648	Not Issued	159	01/08/2002	METHOD AND SYSTEM FOR SORTING DATA	JOHNSTON, WAYNE LESLIE	
60343179	Not Issued	159	12/31/2001	LINEAR INDUCTIVE PLASMA PUMP FOR PROCESS REACTORS	JOHNSON, WAYNE L.	
60337171	Not Issued	159	12/10/2001	METHOD AND DEVICE FOR REMOVING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	JOHNSON, WAYNE	
60302361	Not Issued	159	07/03/2001	INTER-STAGE PLASMA SOURCE	JOHNSON, WAYNE L.	
60272453	Not Issued	159	03/02/2001	METHOD AND APPARATUS FOR ACTIVE TEMPERATURE CONTROL OF SUSCEPTORS	JOHNSON, WAYNE L.	
60262642	Not Issued	159	01/22/2001	VERTICALLY TRANSLATABLE CHUCK ASSEMBLY AND METHOD FOR A PLASMA REACTOR SYSTEM	JOHNSON, WAYNE L.	
60256387	Not Issued	159	12/19/2000	WAFER BIAS DRIVE FOR A PLASMA SOURCE	JOHNSON, WAYNE L.	
60246113	Not Issued	159	11/07/2000	METHOD OF FABRICATING OXIDES WITH LOW DEFECT DENSITIES	JOHNSON, WAYNE L	
60245212	Not Issued	159	I	HALL EFFECT ION SOURCE AT HIGH CURRENT DENSITY	JOHNSON, WAYNE	
60242714	Not Issued	159		METHOD OF AND STRUCTURE FOR CONTROLLING ELECTRODE TEMPERATURE	JOHNSON, WAYNE L.	
60239436	Not Issued	159	- 11	SYSTEM & METHOD FOR WIRELESS TRACKING	JOHNSON, WAYNE	
60238946	Not	159	10/09/2000	DISPLAYING HIERARCHICAL	JOHNSON,	

	Issued			RELATIONSHIP OF DATA ACCESSED VIA SUBJECT INDEX	WAYNE L.
60233623	Not Issued	159	09/18/2000	TUNABLE FOCUS RING FOR PLASMA PROCESSING	JOHNSON, WAYNE L.
60200354	Not Issued	159	04/28/2000	METHOD AND APPARATUS FOR DISTRIBUTING GAS WITHIN HIGH DENSITY PLASMA PROCESS CHAMBER TO ENSURE UNIFORM PLASMA	JOHNSON, WAYNE L.
10325828	Not Issued	051	12/23/2002	LINEAR INDUCTIVE PLASMA PUMP FOR PROCESS REACTORS	JOHNSON, WAYNE L.
10323917	6690568	150	12/20/2002	FLUID DIELECTRIC VARIABLE CAPACITOR	JOHNSON, WAYNE L.
10307484	Not Issued	030	12/02/2002	APPARATUS AND METHOD FOR IMPROVING ELECTRON ECCELERATION	JOHNSON, WAYNE L.
10291763	Not Issued	030	11/12/2002	METHOD OF ADJUSTING THE THICKNESS OF AN ELECTRODE IN A PLASMA PROCESSING SYSTEM	JOHNSON, WAYNE L.
10283358	<u>6729850</u>	150	10/30/2002	APPLIED PLASMA DUCT SYSTEM	JOHNSON, WAYNE L.
10259845	Not Issued	020	09/30/2002	OPTICAL MONITORING AND CONTROL SYSTEM AND METHOD FOR PLASMA REACTORS	JOHNSON, WAYNE L.
10258606	Not Issued	030	06/02/2003	MEASURING PLASMA UNIFORMITY IN-SITU AT WAFER LEVEL	JOHNSON, WAYNE L
10247561	Not Issued	041	09/20/2002	CHUCK TRANSPORT METHOD AND SYSTEM	JOHNSON, WAYNE L.
10239857	Not Issued	030		METHOD AND APPARATUS FOR DISTRIBUTING GAS WITHIN HIGH DENSITY PLASMA PROCESS CHAMBER TO ENSURE UNIFORM PLASMA	JOHNSON, WAYNE L.
10229036	Not Issued	020		ELECTRICALLY CONTROLLED PLASMA UNIFORMITY IN A HIGH DENSITY PLASMA SOURCE	JOHNSON, WAYNE L.
10227527	Not Issued	030			JOHNSON, WAYNE

10227526	Not Issued	095	08/26/2002	METHOD AND APPARATUS FOR DEPOSITING FILMS	JOHNSON, WAYNE L.
10222991	Not Issued	061	08/19/2002	WEATHER RESISTANT ANTI- SLIP PANELS	JOHN, WAYNE MORGAN
10218090	Not Issued	030	08/14/2002	STRUCTURE AND THE METHOD FOR MEASURING THE SPECTRAL CONTENT OF AN ELECTRIC FIELD AS A FUNCTION OF POSITION INSIDE A PLASMA	JOHNSON, WAYNE L.
10218036	Not Issued	030	08/14/2002	METHOD AND DEVICE FOR ATTENUATING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	JOHNSON, WAYNE L.
10218029	Not Issued	092	08/14/2002	ACTIVE CONTROL OF ELECTRON TEMPERATURE IN AN ELECTROSTATICALLY SHIELDED RADIO FREQUENCY PLASMA SOURCE	JOHNSON, WAYNE L.
10204448	Not Issued	061	09/03/2002	HIGH SPEED PHOTORESIST STRIPPING CHAMBER	JOHNSON, WAYNE L
10204263	Not Issued	094		HIGH SPEED STRIPPING FOR DAMAGED PHOTORESIST	JOHNSON, WAYNE L
10204002	Not Issued	093	08/16/2002	ESRF SOURCE FOR ION PLATING EPITAXIAL DEPOSITION	JOHNSON, WAYNE L.
10201560	Not Issued	071	07/23/2002	PACKAGE FOR REMOVABLE DEVICE TIPS	JOHNSON, WAYNE
10189425	Not Issued	041	07/08/2002	SEGMENTED ELECTRODE APPARATUS AND METHOD FOR PLASMA PROCESSING	JOHNSON, WAYNE
10175806	Not Issued	041	06/21/2002	METHOD AND SYSTEM FOR REDUCING DAMAGE TO SUBSTRATES DURING PLASMA PROCESSING WITH A RESONATOR SOURCE	JOHNSON, WAYNE L.
10168544	Not Issued	041		METHOD OF WAFER BAND- EDGE MEASUREMENT USING TRANSMISSION SPECTROSCOPY AND A PROCESS FOR CONTROLLING THE TEMPERATURE UNIFORMITY OF A WAFER	JOHNSON, WAYNE L.
10149452	6630364	150		SYSTEM FOR AUTOMATIC CONTROL OF THE WALL BOMBARDMENT TO CONTROL WALL DEPOSITION	JOHNSON, WAYNE L.

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10043270	<u>6740842</u>	150	01/14/2002	RADIO FREQUENCY POWER SOURCE FOR GENERATING AN INDUCTIVELY COUPLED PLASMA	JOHNSON, WAYNE L.
10031374	6741944	150	05/22/2002	ELECTRON DENSITY MEASUREMENT AND PLASMA PROCESS CONTROL SYSTEM USING A MICROWAVE OSCILLATOR LOCKED TO AN OPEN RESONATOR CONTAINING THE PLASMA	JOHNSON, WAYNE L.
09871026	Not Issued	168	05/31/2001	METHOD FOR PREVENTING TELESCOPING OF SPIRAL WOUND FILTRATION MODULES	JOHNSON, WAYNE
<u>09813936</u>	Not Issued	071	03/22/2001	WEATHER RESISTANT ANTI- SLIP PANELS	JOHN, WAYNE MORGAN
09774183	6385977	150	02/05/2001	ESRF CHAMBER COOLING SYSTEM AND PROCESS	JOHNSON, WAYNE L.
09774182	6491742	150		ESRF COOLANT DEGASSING PROCESS	JOHNSON, WAYNE L.
09749469	6422825	150	12/28/2000	PLASMA VACUUM PUMPING CELL	JOHNSON, WAYNE L.
09707182	6522823	150	11/06/2000	LOW PROFILE CABLE EXIT TROUGH	JOHNSON, WAYNE
09684643	6470129			MODULAR CABLE MANAGEMENT TROUGH SECTION	JOHNSON, WAYNE
09680779	6535683	150	10/06/2000	CABLE EXIT TROUGH WITH COVER	JOHNSON, WAYNE
09680700	6625373	150		INSERT	JOHNSON, WAYNE
09661895	6358241	150	09/14/2000	PACKAGE FOR REMOVABLE DEVICE TIPS	JOHNSON, WAYNE

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Your Search was:

Last Name = KETTLEWELL

First Name = NEIL

Application#	Patent#	Status	Date Filed	Title	Inventor Name 2
10222991	Not Issued	061		WEATHER RESISTANT ANTI-SLIP PANELS	KETTLEWELL, NEIL
09813936	Not Issued	071	03/22/2001	WEATHER RESISTANT ANTI-SLIP PANELS	KETTLEWELL, NEIL

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Your Search was:

Last Name = RIPLEY

First Name = CATHERINE

Application#	Patent#	Status	Date Filed	Title	Inventor Name 5
<u>29091754</u>	D425627	150	1 1	ROAD SPEED HUMP COMPONENT	RIPLEY , CATHERINE JANET
29073341	D402669	150	07/07/1997	LINE MARKER	RIPLEY , CATHERINE J.
10222991	Not Issued	061		WEATHER RESISTANT ANTI-SLIP PANELS	RIPLEY, CATHERINE JANET
09813936	Not Issued	071		WEATHER RESISTANT ANTI-SLIP PANELS	RIPLEY, CATHERINE JANET
09117398	6102305	150	1	LINE MARKING APPLICATORS	RIPLEY , CATHERINE J.

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